

UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT(S) Alexander L. Barr et al GROUP ART UNIT: 2823
APPLN. NO.: 10/780,143 EXAMINER: William D. Coleman
FILED: February 17, 2004
TITLE: SEMICONDUCTOR STRUCTURE HAVING STRAINED
SEMICONDUCTOR AND METHOD THEREFOR

Certificate of Submission

I hereby certify that this correspondence is being submitted to the U.S.P.T.O., Alexandria, VA.

- ☐ Addressed per C.F.R. § 1.1(a) and deposited with the United States Postal Service with sufficient postage as first class mail.
- ☐ Facsimile transmitted in accordance with C.F.R. § 1.6(d).
- ☒ Submitted electronically via EFS in accordance with "Legal Framework for EFS Web".

October 11, 2006

Date of Submission

/Stacie Herrera/

Signature

Stacie Herrera

Printed Name of Person Signing Certificate

PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Please enter the following amendments in the above-entitled application, without prejudice or disclaimer.